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	Filing Date		2006-04-19		
	First Named Inventor	Karg e	et al.		
	Art Unit				
	Examiner Name				
	Attorney Docket Numb	er	CH920030009US1		

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	2	Selective area oxidation of silicon 2691-2693, 1993-5-24	with a scanning force mirco	scope	e, H.C. Day, et al, Applied Physic Lett	ers, Vol. 62,		
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